Applicant(s): Vaartstra et al.

Serial No. Unknown (Parent Serial No. 10/230,131)

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For: SYSTEMS AND METHODS FOR FORMING STRONTIUM- AND/OR BARIUM-CONTAINING LAYERS

Remarks

Please cancel claims 1-60 as requested in the Request for Filing A Continuation Patent Application Under Rule §1.53(b), filed concurrently herewith.

The new claims 61-114 are supported by the originally filed claims and the specification at, for example, page 3, line 11; and page 7, line 19 to page 8, line 10.

Conclusion

The Examiner is invited to contact Applicants' Representatives at the below-listed telephone number, if there are any questions regarding this Preliminary Amendment or if prosecution of this application may be assisted thereby.

Respectfully submitted for

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I hereby certify that the Transmittal Letter and the paper(s) and/or fee(s), as described hereinabove, are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. 1.10 on the date indicated above and is addressed to the Commissioner for Patents, Mail Stop Patent Appligation, P.O. Box 1450, Alexandria, VA 22313-1450.

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